

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : TAKAMATSU  
Serial No : 10/565,879  
Confirm. No : 7943  
Filed : January 23, 2006  
For : WAFER POLISHING METHOD  
Art Unit : 1792  
Examiner : GOUDREAU, GEORGE A  
Dated : January 28, 2008

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

In response to the Final rejection dated October 31, 2007, please amend the above identified application as follows: